

Notice of References Cited

Application/Control No.

09/751,858

Applicant(s)/Patent Under
Reexamination
SANTOS ET AL.

Examiner

Susanna M. Diaz

Art Unit

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Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
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FOREIGN PATENT DOCUMENTS

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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Susan S. Baum and Cheryl M. O'Donnell, An Approach to Modeling Labor and Machine Down Time in Semiconductor Fabrication, Proceedings Of The 23rd Conference On Winter Simulation, Phoenix, Arizona, ISBN:0-7803-0181-1, Pp. 448-54, 1991.
	V	Alan Dix and Geoffrey Ellis, Starting Simple - Adding Value to Static Visualisation Through Simple Interaction, Proceedings Of The Working Conference On Advanced Visual Interfaces, L'Aquila, Italy, Pp. 124 - 34, 1998.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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